

Due: 23:55, May 1 (Friday night)

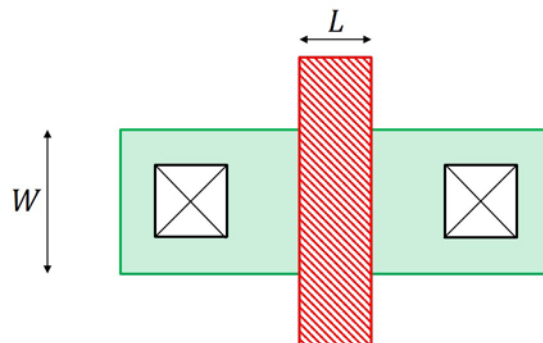
We have 8 problems.

In your answer file, specify both the **SOLUTION PROCEDURE** and the **FINAL SOLUTION**.

1. In the Lecture 10, it was stated that the patterning is done by the photolithography. In this problem, write a report on the photolithography. Clearly identify the references.

2. Visit the TSMC homepage (tsmc.com). You can find the history of the logic technology. A logic technology is specified by its minimum feature size, in our terminology, L . Write the minimum feature size of each technology and its year. (For example, 0.18 micron technology in 1999.)

3. The figure shows a layout of a MOSFET. Consider a larger MOSFET, whose length is $2L$ and width is $3W$. Draw the layouts of the original MOSFET (shown in the figure) and the larger MOSFET.



4. In a PMOSFET, the substrate is doped with N-type dopants. Its source and drain regions are P-type doped. In order to electrically isolate source/drain terminals from the substrate, what is a desirable range of the drain voltage, relative to its substrate voltage?

5. The area of a source region is 1600 nm^2 . An abrupt doping profile is introduced in the source region. The dopant density is $2 \times 10^{20} \text{ cm}^{-3}$. The depth of the source region is 50 nm . Then, how many n-type dopants are found in the source region?

6. In the lecture material of the Lecture 11, a differential equation of $V(x)$ is presented. Solve the differential equation to have analytic expression for $V(x)$. The derivation procedure should be explicitly shown.

7. The threshold voltage of a NMOSFET is 0.8 V . $\mu_n C_{ox} \frac{W}{L}$ is 4 mA/V^2 . Assuming the long-channel MOSFET, calculate the drain current at $V_{GS} = 1.8 \text{ V}$ and $V_{DS} = 0.1 \text{ V}$.

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